Special Symposium | Special Symposium | International Roadmaps on Systems and Devices 2019, Searching xenogeneic technology innovations

[9a-W521-1~11]SP3 International Roadmaps on Systems and Devices 2019, Searching xenogeneic technology innovations

Tetsuya Tatsumi(Sony Semiconductor Solutions), Hitoshi Wakabayashi(Tokyo Tech)

Sat. Mar 9, 2019 9:00 AM - 12:00 PM W521 (W521)

△：Presentation by Applicant for JSAP Young Scientists Presentation Award

▲：English Presentation

▼：Both of Above

No Mark：None of Above

11:50 AM - 12:00 PM

[9a-W521-11]Factory Integration

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Keywords:Factory Integration, Smart Manufacturing, Data Security

The presentation explains major updates in the Factory Integration (FI) Chapter of IRDS2018, namely, more comprehensive approaches to the Smart Manufacturing tenets as well as a new section for Security of Factory information systems, data, and production systems.

In addition, the FI focus for IRDS 2019 will be introduced to ask for inputs from the audience.